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10785618 - GAI: 2613

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10785618
	Filing Date		2004-02-23
	First Named Inventor	Christopher M. Look	
	Art Unit	2613	
	Examiner Name	Leung, Wai Lun	
	Attorney Docket Number	8433P009	

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